

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	435	terada-yoshio.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:18
L2	4759	terada-y\$.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:19
L3	31	terada-y\$.in. and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:19
L4	46	namikawa-makoto.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:43
L5	676	namikawa-m\$.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:43
L6	14	namikawa-m\$.in. and polyimide	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:43
L7	54	uenda-daisuke.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:44
L8	97	uenda-d\$.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:45
L9	21	funatsu-asami.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:45
L10	146	funatsu-a\$.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:46
L11	6827	support same polyimide same adhesive or releas\$ same clean\$3 same (semiconductor or carrying adj1 member or wafer or silicon or flat adj1 panel or disc)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 18:56

L12	1	support same polyimide same adhesive same releas\$ same clean\$3 same (semiconductor or carrying adj1 member or wafer or silicon or flat adj1 panel or disc)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 19:00
L13	3	polyimide same adhesive same releas\$ same clean\$3 same (semiconductor or carrying adj1 member or wafer or silicon or flat adj1 panel or disc)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/06/14 19:06

6/14/08 7:11:46 PM**C:\My Documents\EAST\Workspaces\%lorna.wsp**